



S/N/09/858337

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: William J. Schaff et al.

Examiner: Khanh B Duong

Serial No.: 09/858337 ✓

Group Art Unit: 2822

Filed: May 15, 2001

Docket No.: 1153.04 US1

Title: AIN COATED HETEROJUNCTION FIELD EFFECT TRANSISTOR AND METHOD
OF FORMING AN AIN COATING

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Commissioner for Patents
Washington, D.C. 20231

Applicant has reviewed the Office Action mailed on November 4, 2002. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a two-month extension of the period for responding to the Office action, thereby moving the deadline for response from February 4, 2003 to April 4, 2003.

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